



Docket No.: 50090-275

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: **RESPONSE UNDER 37 CFR 1.116**
: **EXPEDITED PROCEDURE**

Hiroki SHINKAWATA

:

Serial No.: 09/766,846

: Group Art Unit: 2811

Filed: January 23, 2001

: Examiner: Hung K. Vu

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For: SEMICONDUCTOR DEVICE WITH TRANSFER GATE HAVING GATE
INSULATING FILM AND GATE ELECTRODE LAYER

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F JONES
10-30-02

AMENDMENT UNDER 37 CFR §1.116

Box AF
Commissioner for Patents
Washington, DC 20231

Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated July 26, 2002, pursuant to the provisions of 37 C.F.R. §1.116.

IN THE CLAIMS:

Please amend claims 1, 2, 9, 13 and 15 as follows.

1. (Amended) A semiconductor device, comprising:

conductive transfer gates;

contact plugs adjacent to said conductive transfer gates, each contact plug and each
conductive transfer gate having a respective upper surface, wherein the upper surfaces of the
contact plugs and the upper surfaces of the conductive transfer gates are substantially coplanar;
said each conductive transfer gate having a gate insulating film,